

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
 )  
Shunpei Yamazaki et al. )  
 )  
Serial No.: 09/544,801 )  
 )  
Filed: April 7, 2000 )  
 )  
For: Semiconductor Device And Method )  
For Fabricating The Same )  
 )  
Art Unit: 2826 )  
 )  
Confirmation No.: 1717 )  
 )  
Examiner: Fazli Erdem )

*Submission  
w/ reply  
Agent  
01/28/08*

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT (J) AFTER ALLOWANCE**

Sir:

In furtherance of the Notice of Allowance of October 10, 2007, please amend the above-identified application as follows: